

Fee Only

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPL. NO: 10/055,320

ART UNIT: 2825

APPLICANTS: Neil J. Bassom et al.

EXAMINER: Renzo Rocchegiani

FILING DATE: January 23, 2002

TITLE: Fabrication of High Resistivity Structures Using Focused Ion Beams

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REQUEST FOR ONE-MONTH EXTENSION OF TIME

Assistant Commissioner for Patents  
Washington, D.C. 20231

Applicants request that the time for responding to the September 23, 2003 Office action be extended one month to January 23, 2004. The Office is hereby authorized to charge the \$110.00 extension fee and any other fees associated with this filing to Deposit Account 50-01635. A duplicate copy of this authorization is attached.

Respectfully submitted,

Date: 12-24-03

By

Erik Nordstrom

Erik R. Nordstrom  
Patent Reg. No.: 39,792  
P.O. Box 164140  
Austin, Texas 78716-4140  
Telephone: (512) 238-7253  
Facsimile: (512) 306-1963

CERTIFICATE OF FACSIMILE

I hereby certify that this paper or fee is being transmitted via facsimile 01-703-872-9306 to the Assistant Commissioner for Patents, (TC2800) Washington, D.C. 20231, December 24, 2003.

By: Erik Nordstrom  
Name: Erik R. Nordstrom